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	Filing Date		2006-09-29	
	First Named Inventor	Hagen Klauk		
	Art Unit			
	Examiner Name			
Attorney Docket Number		1433.251.101/14187		

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1	S. Takao et al., "Integration of Organic Field-Effect Transistors and Rubbery Pressure Sensors for Artificial Skin Applications", International Electron Devices Meeting 2003, IEDM, Technical Digest, Washington, DC, Dec. 8-10, 2003, New York, NY, pp. 203-206.	<input type="checkbox"/>
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